

## EAST Search History

| Ref # | Hits | Search Query   | DBs  | Default Operator | Plurals | Time Stamp          |
|-------|------|--|--|------------------|---------|---------------------|
| L1    | 7371 | anti\$1static near3<br>(((cinematographic<br>radiographic photographic)<br>adj film) film)               | US-PGPU<br>B;<br>USPAT;<br>USOCR;<br>EPO;<br>JPO;<br>DERWEN<br>T;<br>IBM_TDB | OR               | ON      | 2007/04/04<br>20:21 |
| L2    | 81   | 1 and (static near3 (trouble<br>defect outbreak))  | US-PGPU<br>B;<br>USPAT;<br>USOCR;<br>EPO;<br>JPO;<br>DERWEN<br>T;<br>IBM_TDB | OR               | ON      | 2007/04/04<br>21:07 |
| L3    | 61   | 2 and (simulat\$3 measur\$3<br>test\$3)  | US-PGPU<br>B;<br>USPAT;<br>USOCR;<br>EPO;<br>JPO;<br>DERWEN<br>T;<br>IBM_TDB | OR               | ON      | 2007/04/04<br>20:22 |
| L4    | 6    | 3 and (electrostatic near3<br>charge) and ((surface<br>near3 resistivity) (surface<br>near3 resistance)) | US-PGPU<br>B;<br>USPAT;<br>USOCR;<br>EPO;<br>JPO;<br>DERWEN<br>T;<br>IBM_TDB | OR               | ON      | 2007/04/04<br>21:00 |


  
WPF  
04/04/2007

## EAST Search History

|     |      |   |  |    |     |                  |
|-----|------|---|--|----|-----|------------------|
| L5  | 2    | (step\$1wise with (chang\$3 alter\$5 differ\$4)) same (electrostatic near3 charge) same ((surface near3 resistivity) (surface near3 resistance))            | US-PGPU B;<br>USPAT;<br>USOCR;<br>EPO;<br>JPO;<br>DERWEN T;<br>IBM_TDB | OR | ON  | 2007/04/04 21:02 |
| L6  | 1    | 1 and 5   | US-PGPU B;<br>USPAT;<br>USOCR;<br>EPO;<br>JPO;<br>DERWEN T;<br>IBM_TDB | OR | ON  | 2007/04/04 21:02 |
| L7  | 1    | 5 not 6   | US-PGPU B;<br>USPAT;<br>USOCR;<br>EPO;<br>JPO;<br>DERWEN T;<br>IBM_TDB | OR | ON  | 2007/04/04 21:03 |
| L8  | 6406 | ((427/8) or (427/458) or (427/470) or (427/471) or (427/160) or (427/412.1) or (427/419) or (427/419.1) or (427/419.2) or (427/419.3) or (427/419.5)).CCLS. | US-PGPU B;<br>USPAT;<br>USOCR;<br>EPO;<br>JPO;<br>DERWEN T;<br>IBM_TDB | OR | OFF | 2007/04/04 21:04 |
| L10 | 33   | 1 and 8   | US-PGPU B;<br>USPAT;<br>USOCR;<br>EPO;<br>JPO;<br>DERWEN T;<br>IBM_TDB | OR | ON  | 2007/04/04 21:06 |

## EAST Search History

|     |   |   |  |    |    |                     |
|-----|---|---|--|----|----|---------------------|
| L11 | 1 | 10 and simulat\$3                                 | US-PGPU<br>B;<br>USPAT;<br>USOCR;<br>EPO;<br>JPO;<br>DERWEN<br>T;<br>IBM_TDB | OR | ON | 2007/04/04<br>21:06 |
| L12 | 2 | 8 and (static near3 (trouble<br>defect outbreak)) | US-PGPU<br>B;<br>USPAT;<br>USOCR;<br>EPO;<br>JPO;<br>DERWEN<br>T;<br>IBM_TDB | OR | ON | 2007/04/04<br>21:07 |



## Search Results Attached

Serial Number 10/682,540

Date 04/04/2007

Total Pages of Results 2

WJF  
04/04/2007

Scholar Results 1 - 5 of 5 for ("static marks" OR "static defects") AND (photographic OR radiographic OR cinematographic) AND (anti-static OR antistatic) AND (simulation OR test OR simu

All Results

[M Takimoto](#)

[T Saïda](#)

[M Murata](#)

[C Anderson](#)

[Y Wang](#)

Tip: Looking for pictures? Try [Google Images](#)

Photosensitive materials having improved antistatic property - group of 2 »

[M Takimoto](#), [T Saïda](#), [M Murata](#)... - US Patent 4,495,276, 1985 - Google Patents  
... photosensi-**static marks** are more likely to be generated. ... sensitive ing **photographic** properties. ... without unproved **antistatic** property which comprises a sup- ...

[Cited by 59](#) - [Related Articles](#) - [Web Search](#)

Silver halide **photographic** materials having improved **anti-static** properties - group of 2 »

[T Miyazaki](#), [I Taniya](#), [M Hirose](#)... - US Patent 4,126,467, 1978 - Google Patents  
... **static marks** was carried out by placing a sample of the ... on the sup-65 unexposed **photographic** material on ... with the **anti-static** layer coated surface of the photo ...

[Cited by 4](#) - [Related Articles](#) - [Web Search](#)

**Photographic** film with base containing polymeric **antistatic** material - group of 2 »

[J Greener](#), [D Majumdar](#), [T M Laney](#) - US Patent 6,207,361, 2001 - Google Patents  
... one extruded layer comprising apolymeric **anti-static** material. ... fog pat -terns or "**static marks**" in the ... as **antistatic** layers in **photographic** films comprising a ...

[Cited by 5](#) - [Related Articles](#) - [Web Search](#)

Imaging element comprising an electrically-conductive layer containing conductive fine particles, a ... - group of 3 »

[CC Anderson](#), [Y Wang](#), [J L Bello](#), [I M Shalhoub](#), [D D](#) ... - US Patent 5,466,567, 1995 - Google Patents  
... s) can produce irregular fog pat -terns or "**static marks**" in the emulsion. ... 4,078,935) as being useful in **antistatic** layers for **photographic** applications. ...

[Cited by 19](#) - [Related Articles](#) - [Web Search](#)

Imaging element comprising an electrically-conductive layer exhibiting improved adhesive ... - group of 3 »

[M Leitelai](#), [J Greener](#) - US Patent 5,508,135, 1996 - Google Patents  
... s) can produce irregular fog pat -terns or "**static marks**" in the emulsion. ... 4,078,935) as being useful in **antistatic** layers for **photographic** applications. ...

[Cited by 8](#) - [Related Articles](#) - [Web Search](#)

